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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q66212

KIYOKU, HIROYUKI, et al.

Appln. No.: 09/986,332

Group Art Unit: 1765

Confirmation No.: 5542

Examiner: Matthew A. ANDERSON

Filed: November 08, 2001

For: NITRIDE SEMICONDUCTOR GROWTH METHOD, NITRIDE SEMICONDUCTOR SUBSTRATE, AND NITRIDE SEMICONDUCTOR DEVICE

SUPPLEMENTAL AMENDMENT UNDER 37 C.F.R. § 1.111**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This Amendment is being filed as a supplemental to the Amendment previously filed on September 16, 2004, please amend the above-identified application as follows on the accompanying pages.

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